



EXPEDITED PROCEDURE – EXAMINING GROUP 1763

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Trung T. Doan Examiner: Sylvia MacArthur
Serial No.: 09/652,713 Group Art Unit: 1763
Filed: August 31, 2000 Docket No.: 303.928US5
Title: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER
PROCESSING

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed May 16, 2006, please amend the application as follows:

This response is accompanied by a Petition, as well as the appropriate fee, to obtain a one-month extension of the period for responding to the Office action, thereby moving the deadline for response from August 16, 2006 to September 16, 2006.